



COPY OF PAPERS  
ORIGINALLY FILED

RECEIVED

PATENT

JUL 12 2002

Att'n Docket No. KLAC00012  
TECHNOLOGY CENTER 2800

Eor(1M)  
SDavis  
7/26/02

I CERTIFY THAT ON JUNE 28, 2002, WHICH IS THE DATE I  
AM SIGNING THIS CERTIFICATE, THIS CORRESPONDENCE  
AND IDENTIFIED ENCLOSURES ARE BEING DEPOSITED IN  
THE UNITED STATES POSTAL SERVICE, POSTAGE PAID  
FIRST CLASS, IN AN ENVELOPE ADDRESSED TO:  
COMMISSIONER OF PATENTS AND TRADEMARKS,  
WASHINGTON, D.C. 20231.

STEVEN W. SMYRSKI

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Group Art Unit: 2878

CHRISTOPHER FAIRLEY, ET AL.

Examiner: Eric J. Spears

Title: CONFOCAL WAFER INSPECTION  
METHOD AND APPARATUS

Serial No.: 09/533,203

Filed: MARCH 23, 2000

**PETITION FOR EXTENSION OF TIME**

Asst. Commissioner for Patents  
Washington, DC 20231

Sir:

In accordance with Rule 136, Applicant respectfully petitions the Commissioner for  
a one month extension of time extending to June 28, 2002, the period for response to the

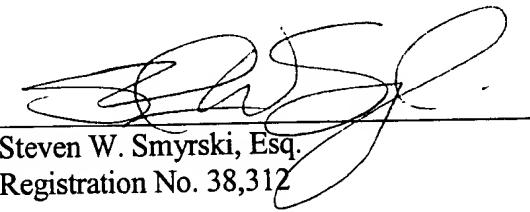
07/11/2002 ANABI1 00000077 09533203

03 FC:115

110.00 0P

Office Action dated February 28, 2002. A check for \$110.00 and the responsive papers are attached.

Respectfully submitted,

  
\_\_\_\_\_  
Steven W. Smyrski, Esq.  
Registration No. 38,312

Date: June 28, 2002

SMYRSKI & LIVESAY, LLP  
3310 Airport Avenue, SW  
Santa Monica, California 90405-6118  
Phone: 310.397.9118  
Fax: 310.397.9158